



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent application of : **Confirmation No. 5534**
Masayoshi HIROSE et al. : Docket No. 2001-0386
Serial No. 09/821,046 : Group Art Unit 3724
Filed February 28, 2002 : Examiner Timothy V. Eley
POLISHING APPARATUS INCLUDING : **MAIL STOP: AMENDMENT**
TURNTABLE WITH POLISHING SURFACE
OF DIFFERENT HEIGHTS

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

In response to the Office Action of March 23, 2005, the period for response to which
having been extended by one month to July 23, 2005, kindly amend the above-referenced U.S.
patent application as follows: